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BAUG

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazuo MAEDA

Serial No.: 09/519,599

Filed: March 6, 2000

For: METHOD AND APPARATUS FOR FORMING

AN INTERLAYER INSULATING FILM,

AND SEMICONDUCTOR DEVICE

2880 #4/IVS 7/8/W

2814

SECOND INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(1)

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

It is respectfully requested that the examiner consider and cite of record the three Kokai publications (18-month publication of an unexamined Japanese Application) listed on the attached, copies of which are submitted herewith. Also submitted herewith are English language abstracts for each of the three Kokai publications.

The three Kokai publications submitted here were cited in an office action dated March 7, 2000 received from the Japanese Patent Office in connection with Japanese Patent Application No. 11-083180, believed to correspond to the captioned case. A copy of



the Japanese Office Action and a partial translation thereof are

also submitted herewith.

Respectfully submitted

George A. Loud Reg. No. 25,814

Dated: April 24, 2000

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